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INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 1 Attorney Docket No. TI-33161

Complete If Known

Application Number

Filing Date

First Named Inventor

Chakravarthi et al.

Group Art Unit

Examiner Name

12/12/01
10/08/03
10/08/03

U.S. PATENT DOCUMENTS

Exam. Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
Y	AA	6,037,640	B1	Lee	03/14/2000	Entire Document
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FOREIGN PATENT DOCUMENTS

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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Exam. Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
Y	CA	"Modeling Solid Source Boron Diffusion for Advanced Transistor Applications", P. PACKAN, S. THOMPSON, E. ANDIDEH, S. YU, M. GILES, J SANDFORD and M. BOHR, 1998 IEEE, IEDM 98-505, 4 Pages.	
Y	CB	"Effect of fluorine on the diffusion of boron in ion implanted Si", Applied Physics Letters, 1998 American Institute of Physics, DANIEL F. DOWNEY, JUDY W. CHOW, EMI ISHIDA and KEVIN S. JONES, Volume 73, Number 9, August 31, 1998, 3 Pages.	
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